

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Patricia B. SMITH et al. Confirmation No.: 3087  
Application Number : 10/647,985  
Filed : August 26, 2003  
Title : POST-ETCH CLEAN PROCESS FOR POROUS LOW  
DIELECTRIC CONSTANT MATERIALS  
TC/Art Unit : 1792  
Examiner: : El Arini, Zeinab  
  
Docket No. : TI-33260 (0025.0184)  
Customer No. : **23494**

**Mail Stop AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**PETITION FOR EXTENSION OF TIME**

Applicants hereby petition for a one month extension of time to reply to the Office Action of January 10, 2008. Please charge the fee of \$120.00 to Texas Instruments' deposit account 20-0668.

Please grant any extensions of time required to enter this response and charge any additional required fees to Texas Instruments' deposit account 20-0668.

Respectfully submitted,

Dated: May 12, 2008

By: 

Timothy M. Nsieh  
Reg. No. 42,672